



Docket No.: 052775-0024

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-----------------------------|---|---------------------------|
| In re Application of | : | Customer Number: 20277 |
| | : | |
| Masahiro NAKAYAMA, et al. | : | Confirmation Number: 1716 |
| | : | |
| Application No.: 10/662,524 | : | Group Art Unit: 3723 |
| | : | |
| Filed: September 16, 2003 | : | Examiner: Dung V. Nguyen |
| | : | |

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the non-final
Office Action dated March 15, 2006.

Amendments to the Claims begin on page 2.

Remarks begin on page 5.